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Notice of Allowability	Application No.	Applicant(s)	
	10/617,703	CHOI ET AL.	
	Examiner	Art Unit	.)
	Kiet T. Nguyen	2881	An
Th MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. This communication is responsive to <u>The election filed on May 25, 2004.</u>			
2. The allowed claim(s) is/are 1-5.			
3. The drawings filed on 14 July 2003 are accepted by the Examiner.			
 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some* c) None of the: 			
1. Certified copies of the priority documents have been received.			
2. Certified copies of the priority documents have been received in Application No			
3. Copies of the certified copies of the priority documents have been received in this national stage application from the			
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application) since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.			
(a) The translation of the foreign language provisional application has been received.			
6. Acknowledgment is made of a claim for domestic priority up in the first sentence of the specification or in an Application	nder 35 U.S.C. §§ 120 and/ Data Sheet. 37 CFR 1.78.	or 121 since a specific referenc	e was included
Applicant has THREE MONTHS FROM THE "MAILING DATE" of below. Failure to timely comply will result in ABANDONMENT of			
7. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			OTICE OF
 8. ☐ CORRECTED DRAWINGS (as "replacement sheets") mus (a) ☐ including changes required by the Notice of Draftspers 1) ☐ hereto or 2) ☐ to Paper No 		w (PTO-948) attached	
(b) ☐ including changes required by the proposed drawing correction filed, which has been approved by the Examiner.			
(c) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No			
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the margin according to 37 CFR 1.121(d).			
9. DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT FOR T			ote the
Attachment(s)			
1⊠ Notice of References Cited (PTO-892)	5☐ Notice of Inf	ormal Patent Application (PTO-	152)
 2 ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3 ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No. 20040612 	6☐ Interview Su	ımmary (PTO-413), Paper No	·
	3), 7□ Examiner's	Amendment/Comment	
4 Examiner's Comment Regarding Requirement for Deposit		Statement of Reasons for Allow	ance
of Biological Material	9☐ Other	Terry	
		KIET T. NGUYEN PRIMARY EXAMINER	

Application/Control Number: 10/617,703

Art Unit: 2881

Applicant's election without traverse of Group I including claims 1-5 filed on May 25, 2004 is acknowledged.

This application is in condition for allowance except for the presence of claims 6-12 to invention non-elected without traverse. Accordingly, claims 6-12 have been cancelled.

The following is an examiner's statement of reasons for allowance:

The prior art fails to disclose a deflector of a micro-column electron beam apparatus, which includes a plurality of deflecting plates formed along circumference of a hole at upper and lower sides of an isolation substrate, a plurality of pads formed on edges of the upper and lower sides of the substrate and a plurality of wirings for connecting each of the deflecting plates and each of the pads as recited in claim 1.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kiet T. Nguyen whose telephone number is 571-272-2479. The examiner can normally be reached on Monday-Friday from 8.00 AM to 6.00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R Lee, can be reached on Monday-Friday. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Application/Control Number: 10/617,703

Art Unit: 2881

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

KIET T. NGUYEN PRIMARY EXAMINER Page 3